Moser Patterson & Sheridan, llp - ATTORNEYS AT LAW

3040 Post Oak Blvd, Suite 1500 Houston, TX 77056-6582 TEL 713.623.4844 FAX 713.623.4845

WWW.MPSLLP.COM

FACSIMILE COVER SHEET

DATE:

June 1, 2004

FILE NO:

AMAT/5262/CMP/CMP/RKK

TO:

Examiner Edna Wong

FAX NO:

571-273-1349

PHONE NO:

571-272-1349

COMPANY:

USPTO

FROM:

Keith M. Tackett

PAGE(S) with cover:

ORIGINAL TO FOLLOW?

☐ YES 図 NO

SECOND RESPONSE TO FINAL OFFICE ACTION DATED FEBRUARY 6, 2004

TITLE:

Method and Apparatus For Forming Metal Layers

U.S. SERIAL NO .: FILING DATE:

09/961,134 September 21, 2001

INVENTOR:

Tsai, et al.

EXAMINER: GROUP ART UNIT:

Edna Wong

1753

CONFIRMATION NO .:

4110

CONFIDENTIALITY NOTE

The document accompanying this facsimile transmission contains information from the law firm of Moser, Patterson & Sheridan, LL.P. which is confidential or privileged. The information is intended to be for the use of the Individual or entity named on this transmission sheet. If you are not the intended recipient, be aware that any disclosure, copying, distribution or use of the contents of this faxed Information is prohibited. If you have received this facsimile in error, please notify us by telephone immediately so that we can arrange for the retrieval of the original documents at no cost